



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No.: 3094/FLK

2825
#4/Ext(1)
9/24/02
RECEIVED
SEP 20 2002
TECHNOLOGY CENTER 2800

Re application of: Minoru Nakano, et al.

Serial No.: 09/675,220

Date: September 12, 2002

Filed: September 29, 2000

Group Art Unit: 2825

For: Method and Apparatus for Controlling a Semiconductor Fabrication Temperature
Examiner: Caridad Everhart

PETITION AND FEE FOR EXTENSION OF TIME (37 CFR 1.135(a))

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

This is a petition for an extension of the time to extend the period for response to the Office Action dated May 14, 2002

- 1. Applicant is not a small entity.
- 2. Extension period and fee:

| | (months) | Fee for other than Small entity |
|-------------------------------------|--------------|------------------------------------|
| <input checked="" type="checkbox"/> | one month | \$110.00 |
| <input type="checkbox"/> | two months | \$ |
| <input type="checkbox"/> | three months | \$ |
| <input type="checkbox"/> | four months | \$ |

Fee: \$110.00

- 3. An amendment/Missing Parts

☒ is filed herewith ☐ has been filed

- 4. Fee Payment

☒ Charge fee to Deposit Account No. 50-1290 and for any additional extension fee required r credit for any excess fee paid. A duplicate copy of this sheet is enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service, as First Class mail, postage pre-paid on 9/24/02 and is addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231

Shahar Islam

FOR: Respectfully submitted,

BY: Attorney, Shahar Islam
Registration No.: 32,507
Tel.: (212) 940-8564

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